



PATENT APPLICATION

RCE/3723 \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#18/Extension
J
(mo)

Date October 17, 2003

In re the Application of

Makoto KOBAYASHI et al.

Group Art Unit: 3723

Application No.: 09/830,434

Examiner: H. Shakeri

Filed: April 26, 2001

Docket No.: 109352

For: POLISHING PAD AND POLISHING METHOD FOR SEMI-CONDUCTOR WAFER

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

RECEIVED

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

OCT 22 2003

TECHNOLOGY CENTER R3700

Sir:

Transmitted herewith is a Request for Continued Examination (RCE) in the above-identified patent application. The shortened statutory period having expired September 17, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 147449 in the amount of \$110 in payment for:

- X Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
- Extension fee for response within second month pursuant to §1.136(a) (\$420.00)
- Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

10/21/2003 AWONDAF1 00000089 09830434
02 FC:1251 110.00 0P

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Joel S. Armstrong
Registration No. 36,430

Christopher W. Brown
Registration No. 38,025

WPB:JSA:CWB/rav

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
Deposit Account No. 15-0461